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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuyoshi NAKATSUKASA et al.**

Serial Number: **Not yet assigned**
(§371 of international application No. PCT/JP2003/015431)

Filed: **February 9, 2006**

For: **METHOD OF PROCESSING SUBSTRATE AND SUBSTRATE
PROCESSING APPARATUS**

Attorney Docket Number: **062032**
Customer Number: **38834**

**SUBMISSION OF SUBSTITUTE PAGES UNDER PCT ARTICLE 34 AND
PRELIMINARY AMENDMENT**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 9, 2006

Sir:

Prior to calculation of the filing fee and examination of this application, please amend the
above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 8 of this paper.